



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Abdurrahman Sezginer et al.

Application No.: 10/613,378

Filed: July 3, 2003

For: OVERLAY METROLOGY METHOD
AND APPARATUS USING MORE
THAN ONE GRATING PER
MEASUREMENT DIRECTION

Confirmation No.: 7200

Group Art Unit: Unknown

Examiner: Unknown

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(37 CFR 1.8(a))**

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I hereby certify that this correspondence is being deposited
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